

Docket No.: WMP-EUP-008



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By: \_\_\_\_\_

Date: July 15, 2004

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applic. No. : 10/056,770 Confirmation No: 4597  
Applicant : Gottfried Ferber et al.  
Filed : January 24, 2002  
Title : Semiconductor Module and Method for Fabricating the  
Semiconductor Module  
Art Unit : 2818  
Examiner : Long K. Tran  
  
Docket No. : WMP-EUP-008  
Customer No. : 24131

INFORMATION DISCLOSURE STATEMENT  
UNDER 37 C.F.R. 1.97(i)

Hon. Commissioner for Patents

Sir:

In accordance with 37 C.F.R. 1.98 copies of the following patents and/or publications are submitted herewith:

United States Patent No. 5,730,543 (Schonauer et al.), dated March 24, 1998, and corresponding International Publication WO 95/18777, dated July 13, 1995;

United States Patent Application Publication US 2002/0033529 A1 (Ferber et al.), dated March 21, 2002, and corresponding International Publication WO 00/55917, dated September 21, 2000;

German Patent De 32 41 508 C2 (Leukel et al.), dated May 10, 1984, and English abstract thereof;

German Published Non-Prosecuted Patent Application DE 195 27 611 A1 (Maier et al.), dated January 30, 1997, substrate and method for producing it;

German Examination report dated August 12, 2003.

If no translation of pertinent portions of any foreign language patents or publications mentioned above is included with the aforementioned copies of those applications, patents and/or publications, it is because no existing translation is readily available to the applicant.

It is believed that the enclosed prior art is less pertinent than the prior art previously submitted and cited by the Examiner. Kindly place the references in the Patent Office file wrapper.

Respectfully submitted,



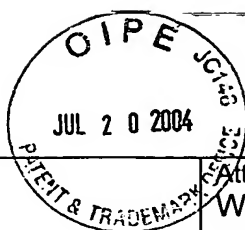
For Applicants

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/bmb



Sheet 1 of 1

FORM PTO-1449 (SUBSTITUTE)

U.S. DEPARTMENT OF COMMERCE  
PATENT AND TRADEMARK OFFICEINFORMATION DISCLOSURE  
STATEMENT BY APPLICANT  
(37 CFR 1.98(b))Attorney Docket No.:  
WMP-EUP-008Applic. No.  
10/056,770

Applicant

Gottfried Ferber et al.

Filing Date  
January 24, 2002Group Art Unit  
2818

## U.S. PATENT DOCUMENTS

EXAMINER INITIALS		PATENT NO.	DATE	PATENTEE	CLASS	SUB CLASS	FILING DATE
	A	5,730,543	03/24/98	Schonauer et al.			
	B	2002/0033529 A1	03/21/02	Ferber et al.			
	C						
	D						
	E						
	F						
	G						
	H						
	I						

## FOREIGN PATENT DOCUMENT

		DOCUMENT NO.	DATE	COUNTRY	CLASS	SUB CLASS	TRANSL. YES   NO
	J	95/18777	07/13/95	WIPO			
	K	00/55917	09/21/00	WIPO			
	L	32 41 508 C2	05/10/84	Germany			
	M	195 27 611 A1	01/30/97	Germany			
	N						

## OTHER DOCUMENTS (Including Author, Title, Date, Pertinent Pages, etc.)

	O	
	P	

EXAMINER

DATE CONSIDERED

EXAMINER: Initial if citation considered, whether or not citation is in conformance with MPEP 609; Draw line through citation if not in conformance and not considered. Include copy of this form with next communication to applicant.